

- Makarov, N. S., M. Drobizhev, et al. (2008). "Two-photon absorption standards in the 550-1600 nm excitation wavelength range." Optics Express **16**(6): 4029-4047.
- Malinauskas, M., M. Farsari, et al. (2013). "Ultrafast laser nanostructuring of photopolymers: A decade of advances." Physics Reports-Review Section of Physics Letters **533**(1): 1-31.
- Maruo, S. and J. T. Fourkas (2008). "Recent progress in multiphoton microfabrication." Laser & Photonics Reviews **2**(1-2): 100-111.
- Moser, H. O. and C. Rockstuhl (2012). "3D THz metamaterials from micro/nanomanufacturing." Laser & Photonics Reviews **6**(2): 219-244.
- Park, S. H., D. Y. Yang, et al. (2009). "Two-photon stereolithography for realizing ultraprecise three-dimensional nano/microdevices." Laser & Photonics Reviews **3**(1-2): 1-11.
- Seidlits, S. K., C. E. Schmidt, et al. (2009). "High-Resolution Patterning of Hydrogels in Three Dimensions using Direct-Write Photofabrication for Cell Guidance." Advanced Functional Materials **19**(22): 3543-3551.
- Shukla, S., E. P. Furlani, et al. (2010). "Two-Photon Lithography of Sub-Wavelength Metallic Structures in a Polymer Matrix." Advanced Materials **22**(33): 3695-+.
- Shukla, S., X. Vidal, et al. (2011). "Subwavelength Direct Laser Patterning of Conductive Gold Nanostructures by Simultaneous Photopolymerization and Photoreduction." Acs Nano **5**(3): 1947-1957.
- Soukoulis, C. M. and M. Wegener (2011). "Past achievements and future challenges in the development of three-dimensional photonic metamaterials." Nature Photonics **5**(9): 523-530.
- Tanaka, T., A. Ishikawa, et al. (2006). "Two-photon-induced reduction of metal ions for fabricating three-dimensional electrically conductive metallic microstructure." Applied Physics Letters **88**(8).
- Vora, K., S. Y. Kang, et al. (2012). "Fabrication of disconnected three-dimensional silver nanostructures in a polymer matrix." Applied Physics Letters **100**(6).
- Xu, B. B., H. Xia, et al. (2010). "Flexible Nanowiring of Metal on Nonplanar Substrates by Femtosecond-Laser-Induced Electroless Plating." Small **6**(16): 1762-1766.